Docket No.

STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: IOSAKA, et al.

SERIAL NO: 10/820,123 GAU:

3723

FILED:

April 8, 2004

EXAMINER: RACHUBA, MAURINA T.

FOR:

ABRASIVE PAD, METHOD AND METAL MOLD FOR MANUFACTURING THE SAME, AND

SEMICONDUCTOR WAFER POLISHING METHOD

# INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

Applicant(s) wish to disclose the following information.

#### REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

#### **RELATED CASES**

- Attached is a list of applicant's pending application(s), published application(s) or issued patent(s) which may be related to the present application. In accordance with the waiver of 37 CFR 1.98 dated September 21, 2004, copies of the cited pending applications are not provided. Cited published and/or issued patents, if any, are listed on the attached PTO form 1449.
- A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

## CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- ☐ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

### DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C. Norman F. Oblon

Bryant L. Young

Regrostage Weer 4, 404 656 10820123

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(Modified)		PATENT AND TRADEMARK OFFICE		251598US0		10/820,123		
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LIST OF	REFER	RENCES CITES BY AF	PLICANT	Yukio HOSAKA, et al.				
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	AA	5,893,796	04/13/1999	BIRANG, et al.				
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FOREIGN PATENT DOCUMENTS								
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	AO	2001-0089717	08/10/2001	Korean (with English abstract)		YES	S NO	
	AP	2001-0089717	10/24/2001	Korean (with English abstract)	-			
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)								
	AW							
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Examiner					Date Considered			
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								